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## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

Ap	pl.	No.
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10/723,714

: Confirmation No.:

Applicant

Bing Ji et al.

Filed

November 26, 2003

For

METHOD FOR ETCHING HIGH DIELECTRIC CONSTANT

MATERIALS AND FOR CLEANING DEPOSITION CHAMBERS FOR

HIGH DIELECTRIC CONSTANT MATERIALS

Art Unit

1763

Examiner

G. Goudreau

Docket No.

06299P2 USA

Customer No.

23543

Commissioner for Patents P.O. Box 1450 Alexandria, VA 22313-1450

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## REPLY PURSUANT TO 37 C.F.R. § 1.111

SII:			
	The following is responsive to the Office Action dated June 15, 2006 ("the Actio		
$\boxtimes$	A one (1) month extension of time is requested and authorization to charge the Account of assignee is provided in an enclosed form.		
	Amendments to the Specification begin on page	of this paper.	
$\boxtimes$	Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.		
	Amendments to the Drawings begin on page attached replacement sheet(s).	of this paper and include an	
	Amendments to the Abstract are on page the Abstract is on page of this paper.	of this paper. A clean version o	
$\boxtimes$	Remarks/Arguments begin on page 5 of this paper	r.	